

[図1]

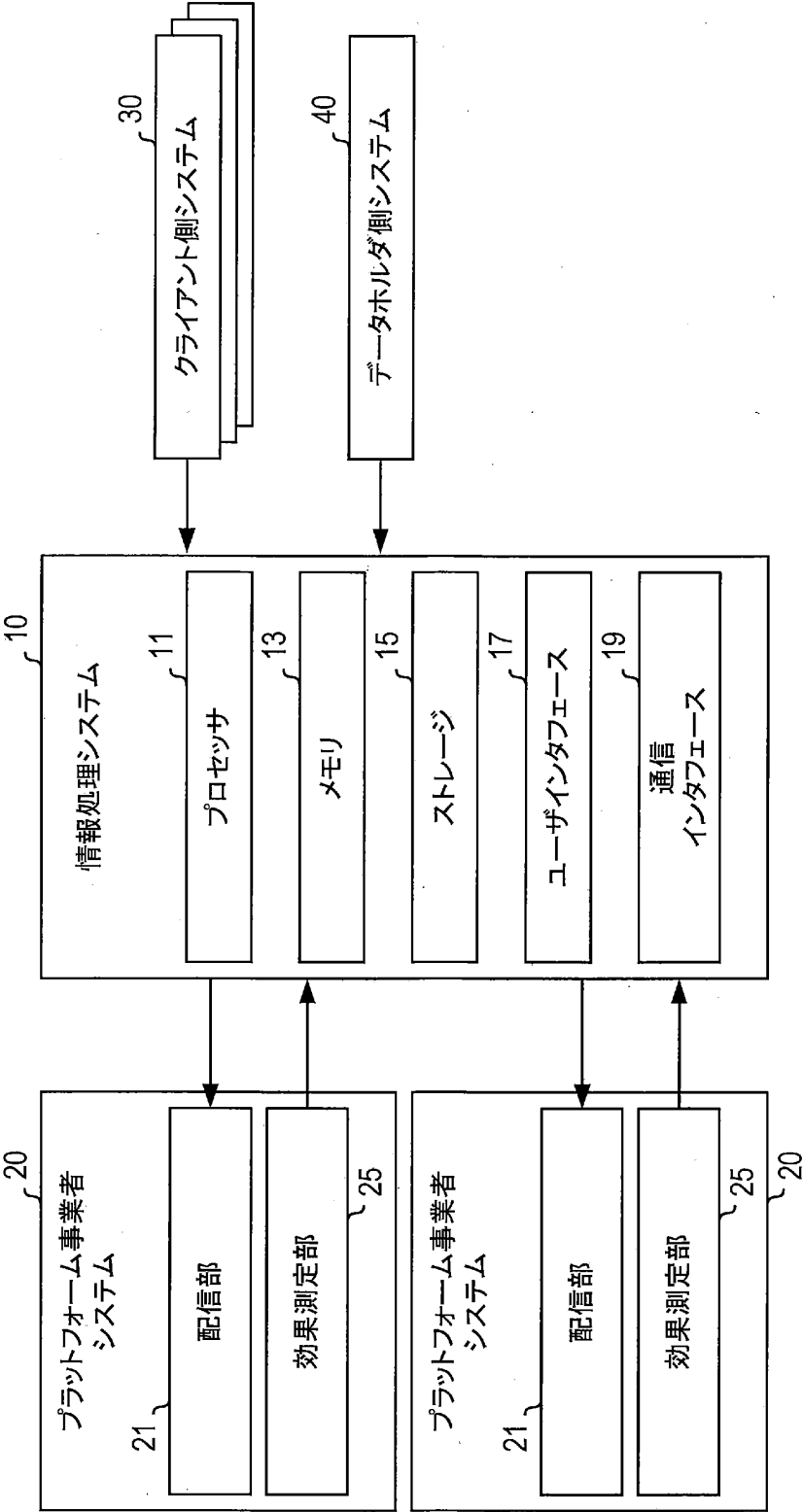


FIG. 1

[図2]

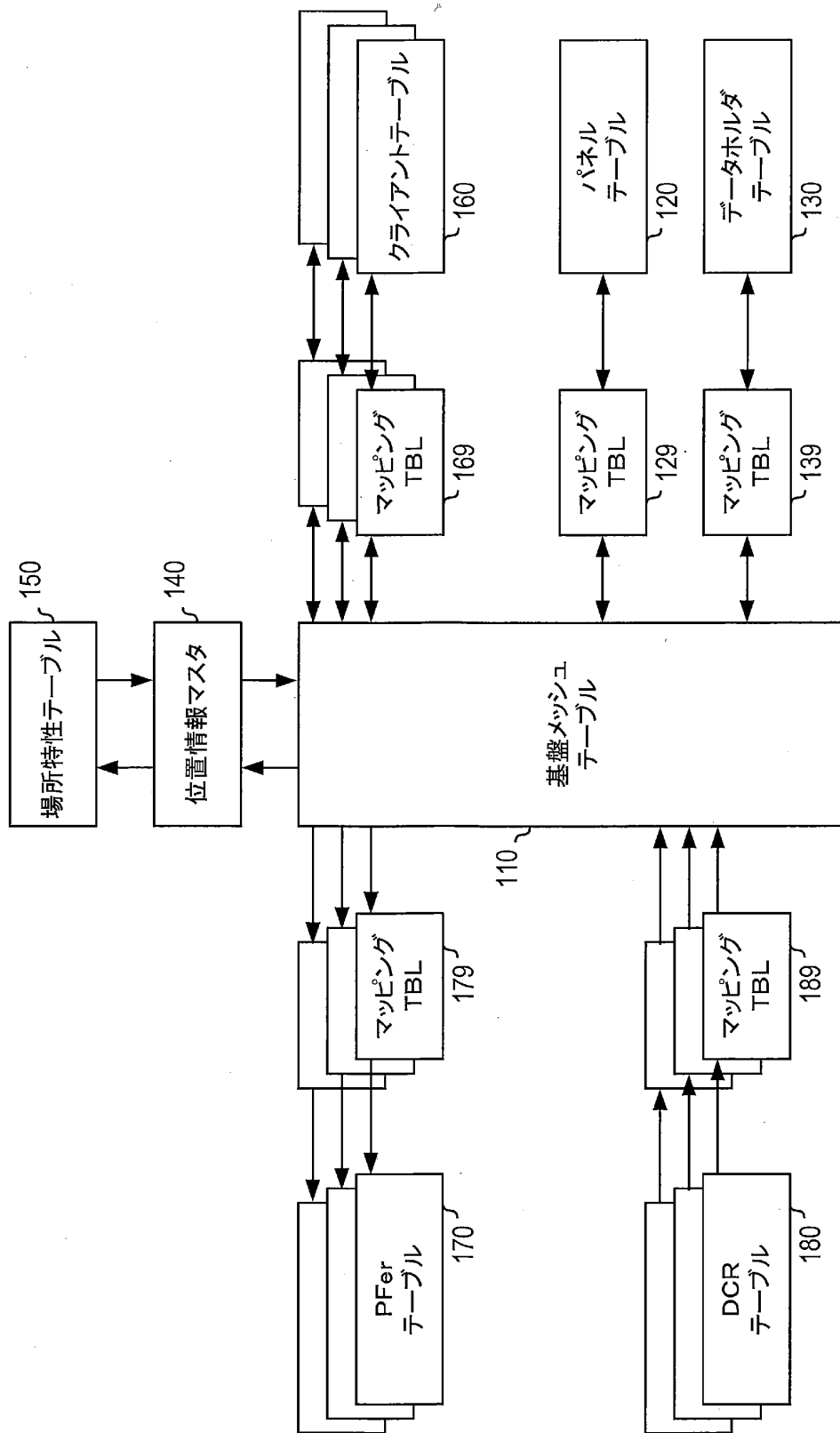


FIG. 2

[図3]

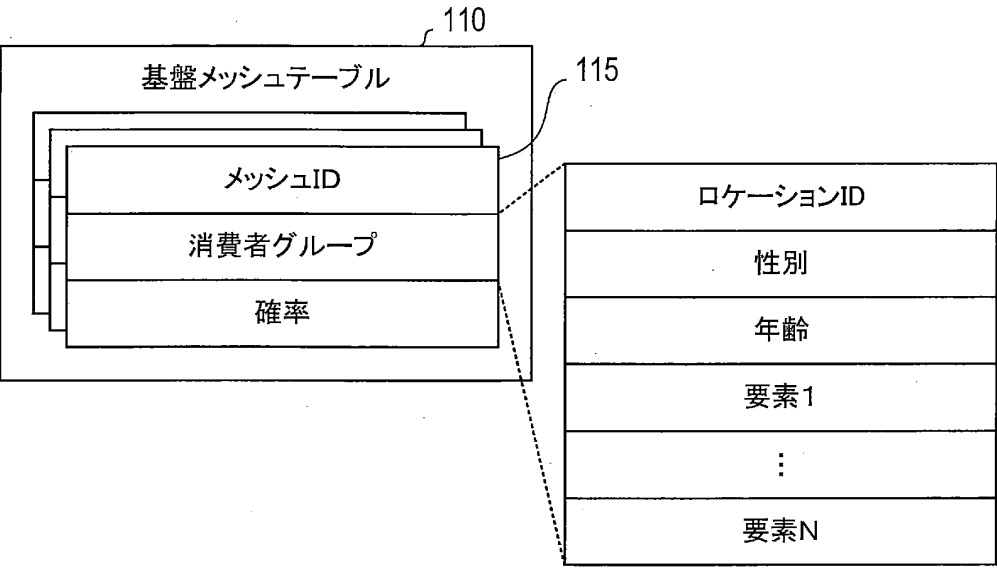


FIG. 3

[図4]

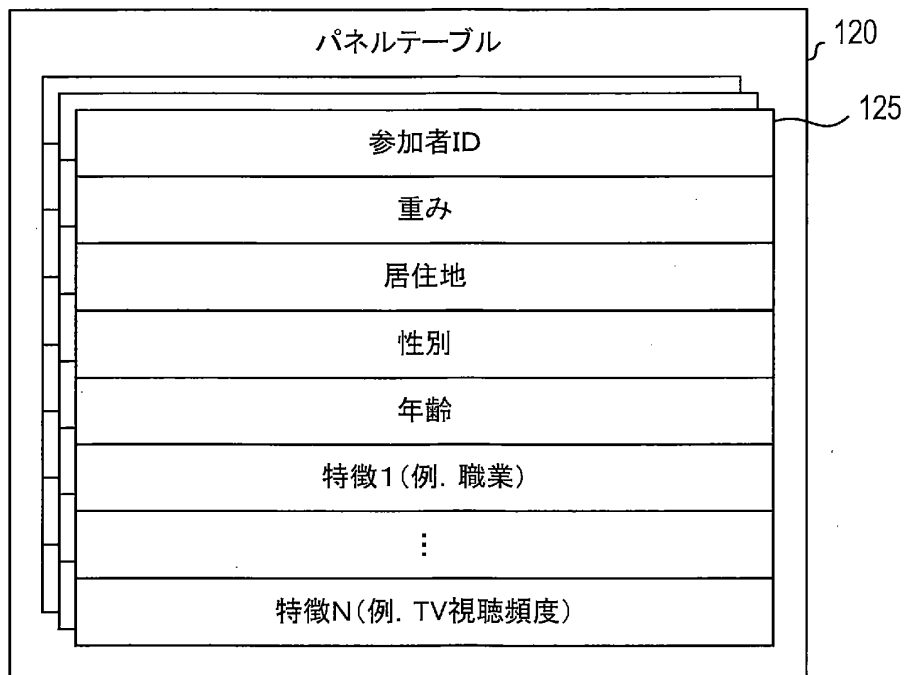


FIG. 4A

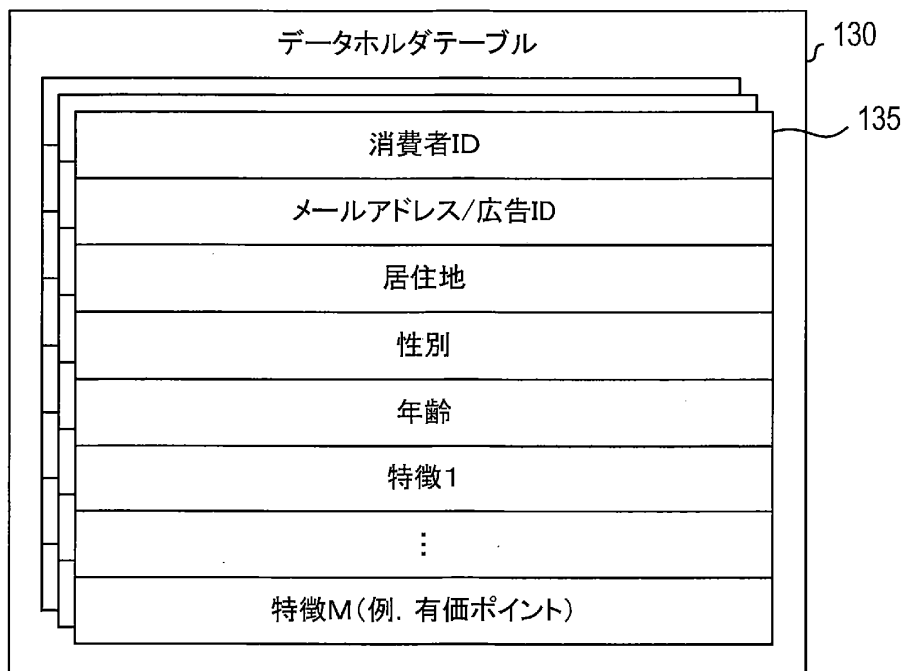


FIG. 4B

[図5]

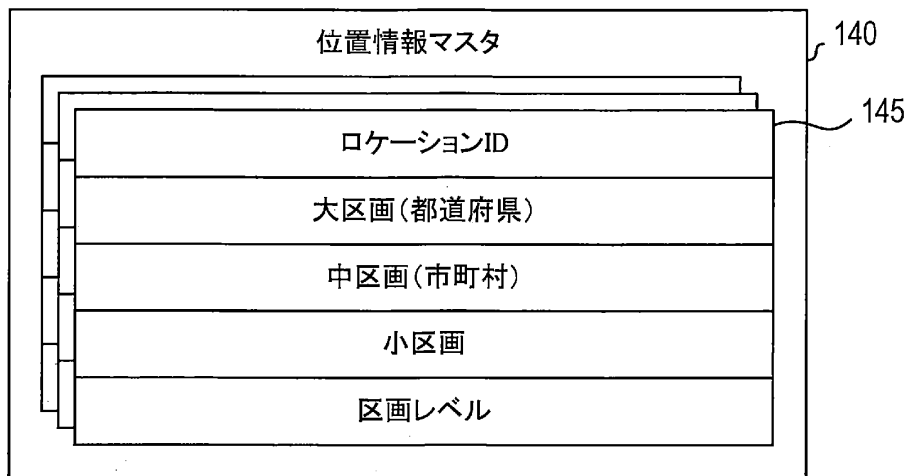


FIG. 5A

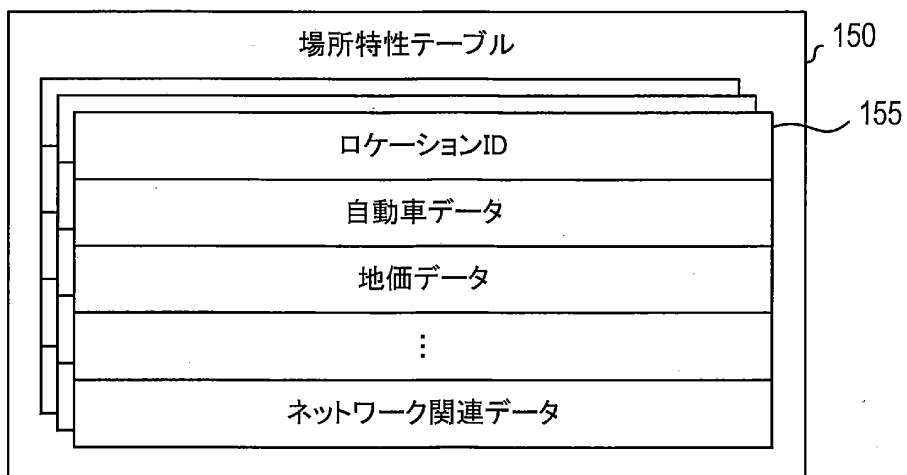


FIG. 5B

[図6]

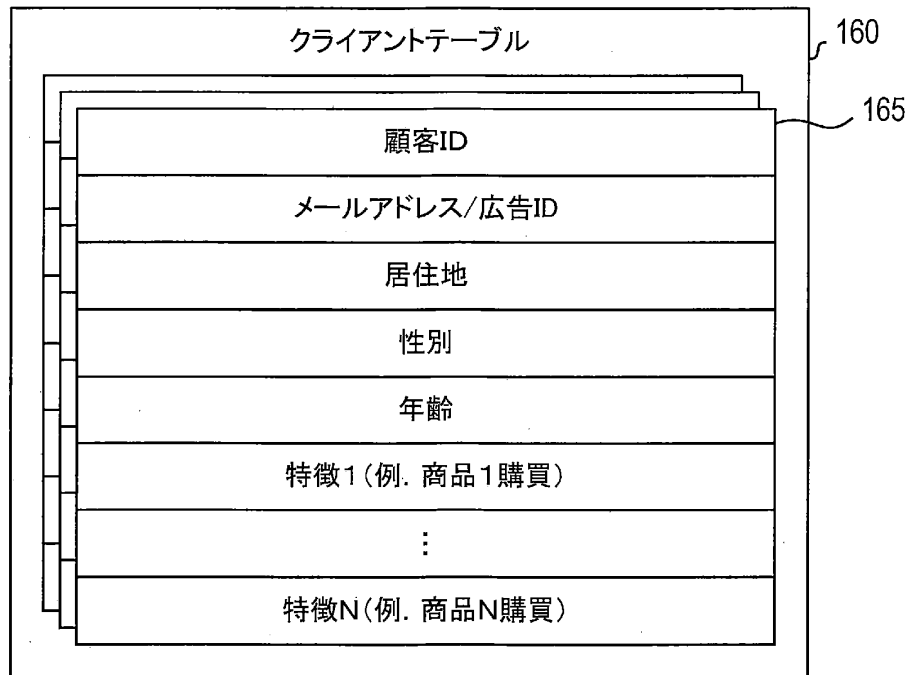


FIG. 6

[図7]

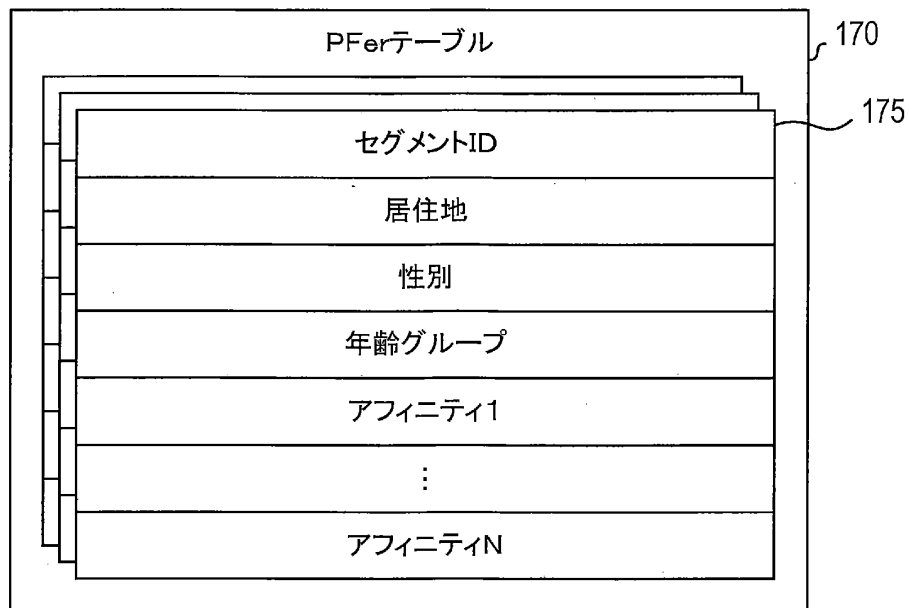


FIG. 7A

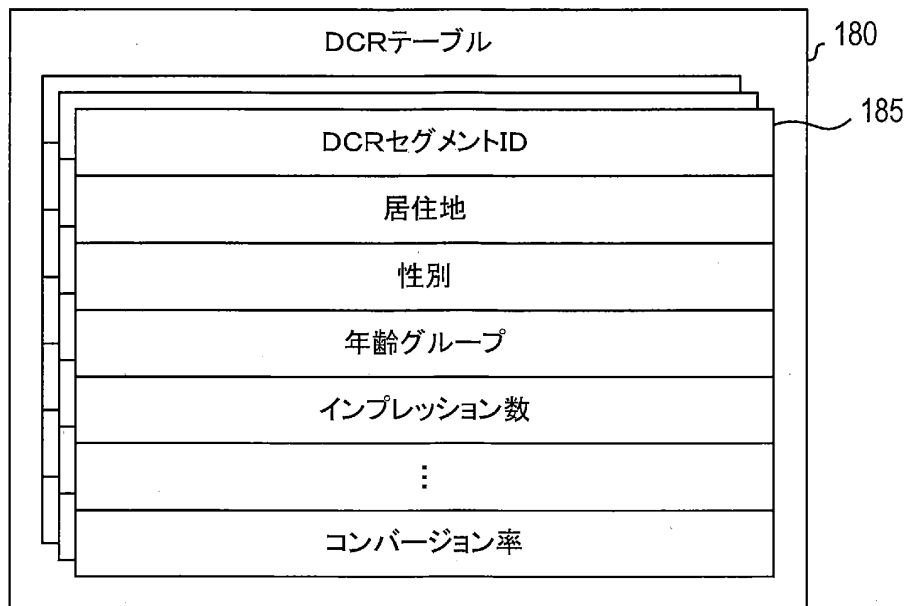


FIG. 7B

[図8]

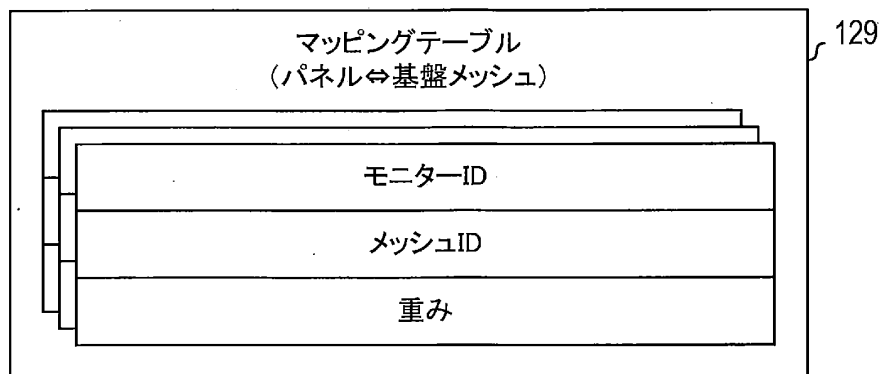


FIG. 8A

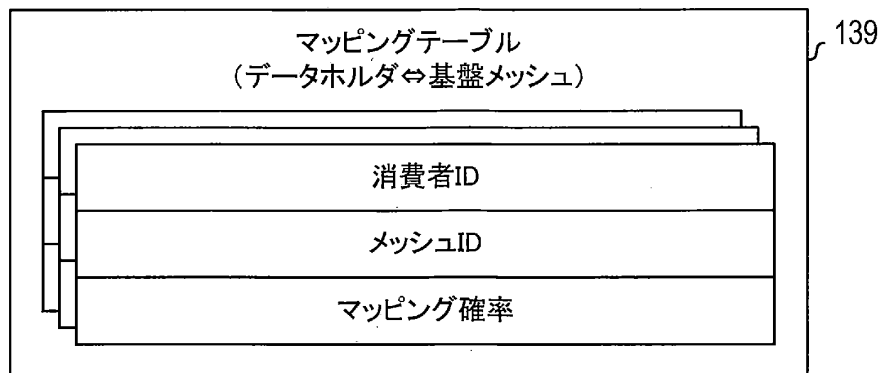


FIG. 8B

[図9]

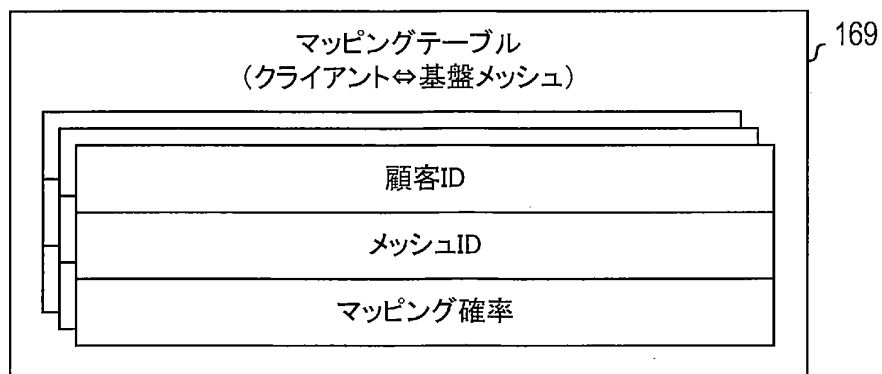


FIG. 9

[図10]

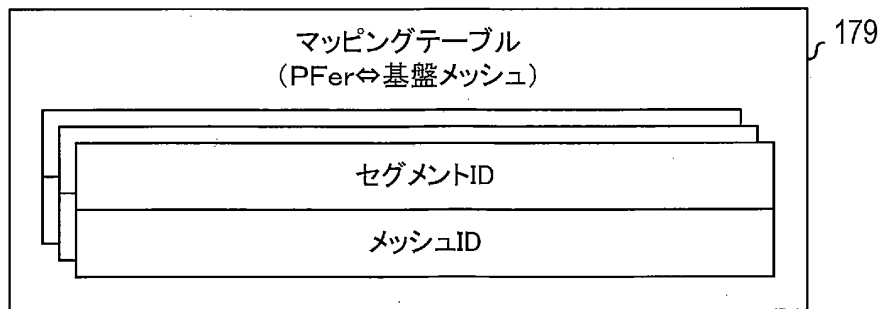


FIG. 10A

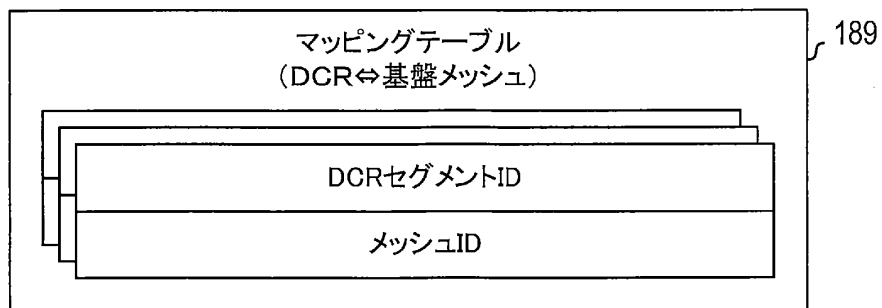


FIG. 10B

[図11]

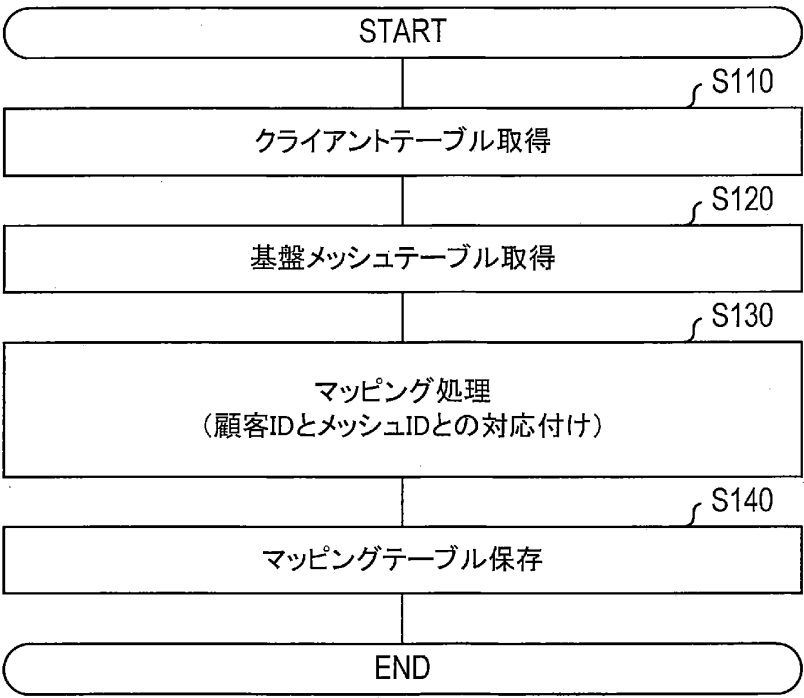


FIG. 11

[図12]

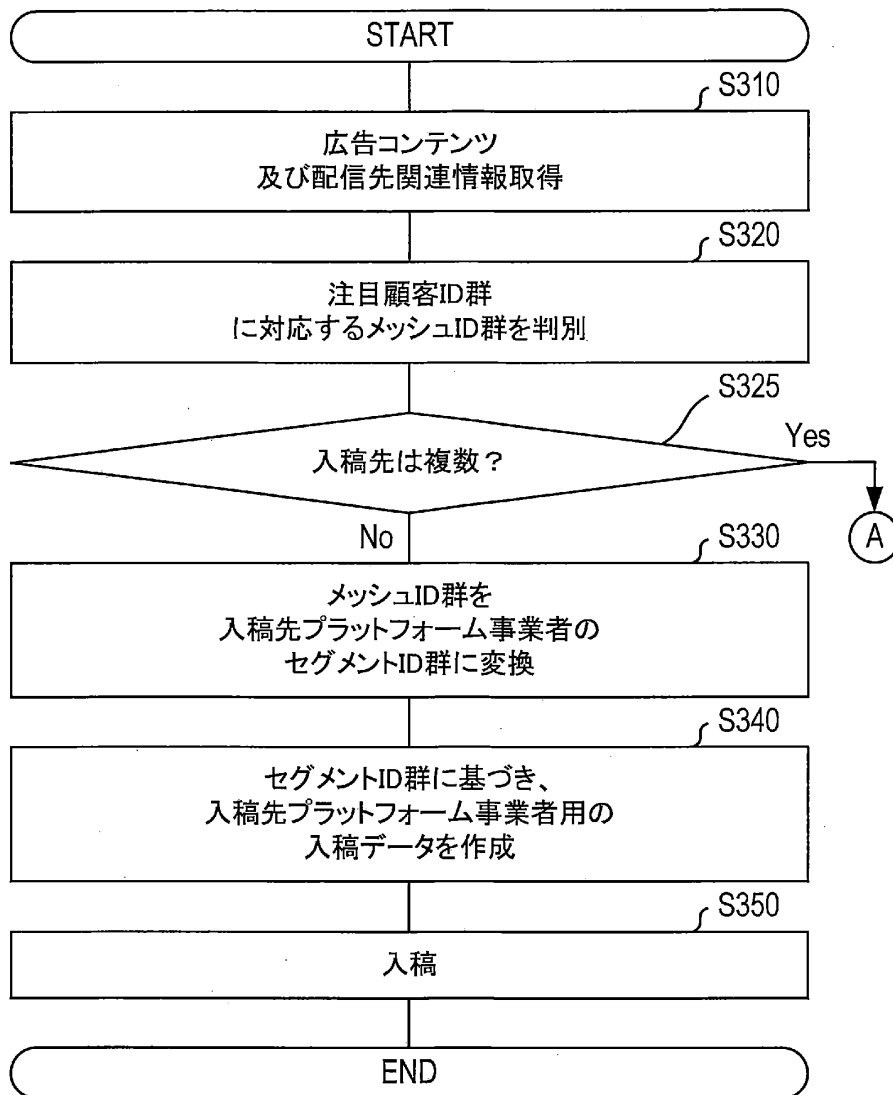


FIG. 12

[図13]

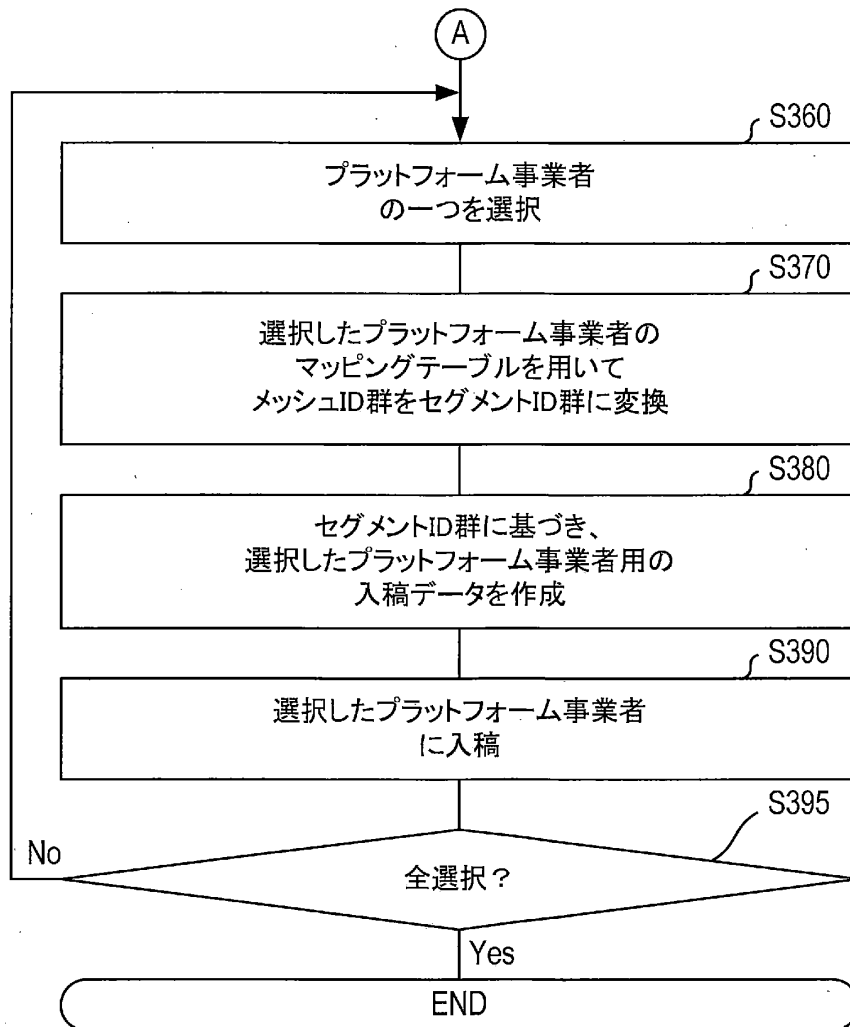


FIG. 13

[図14]

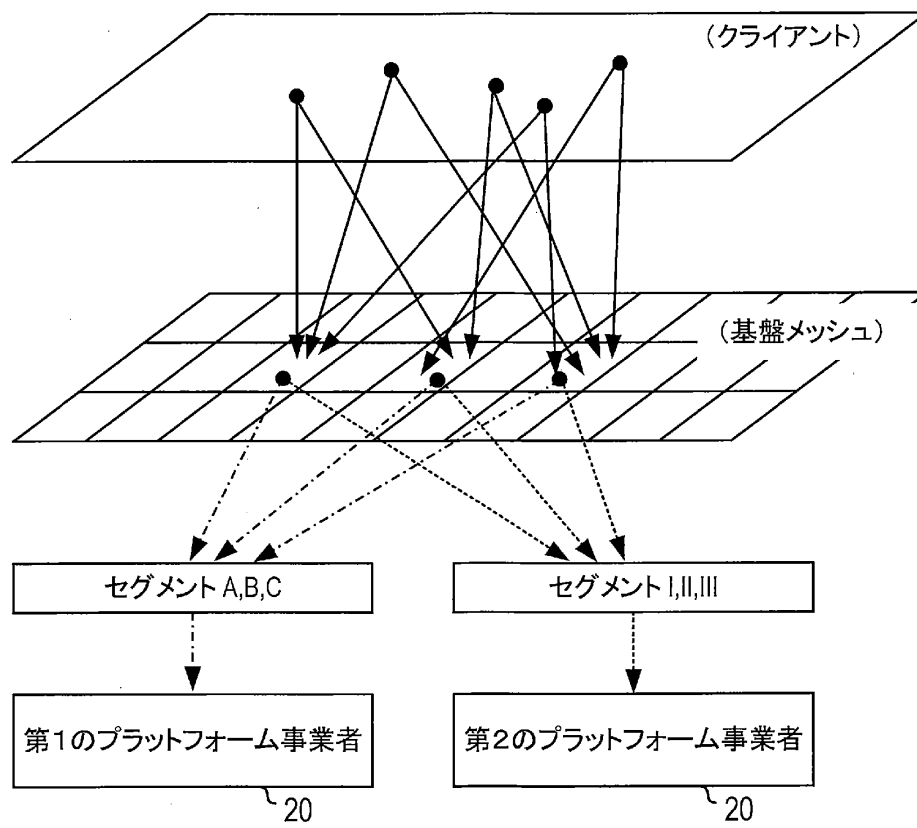


FIG. 14

[図15]

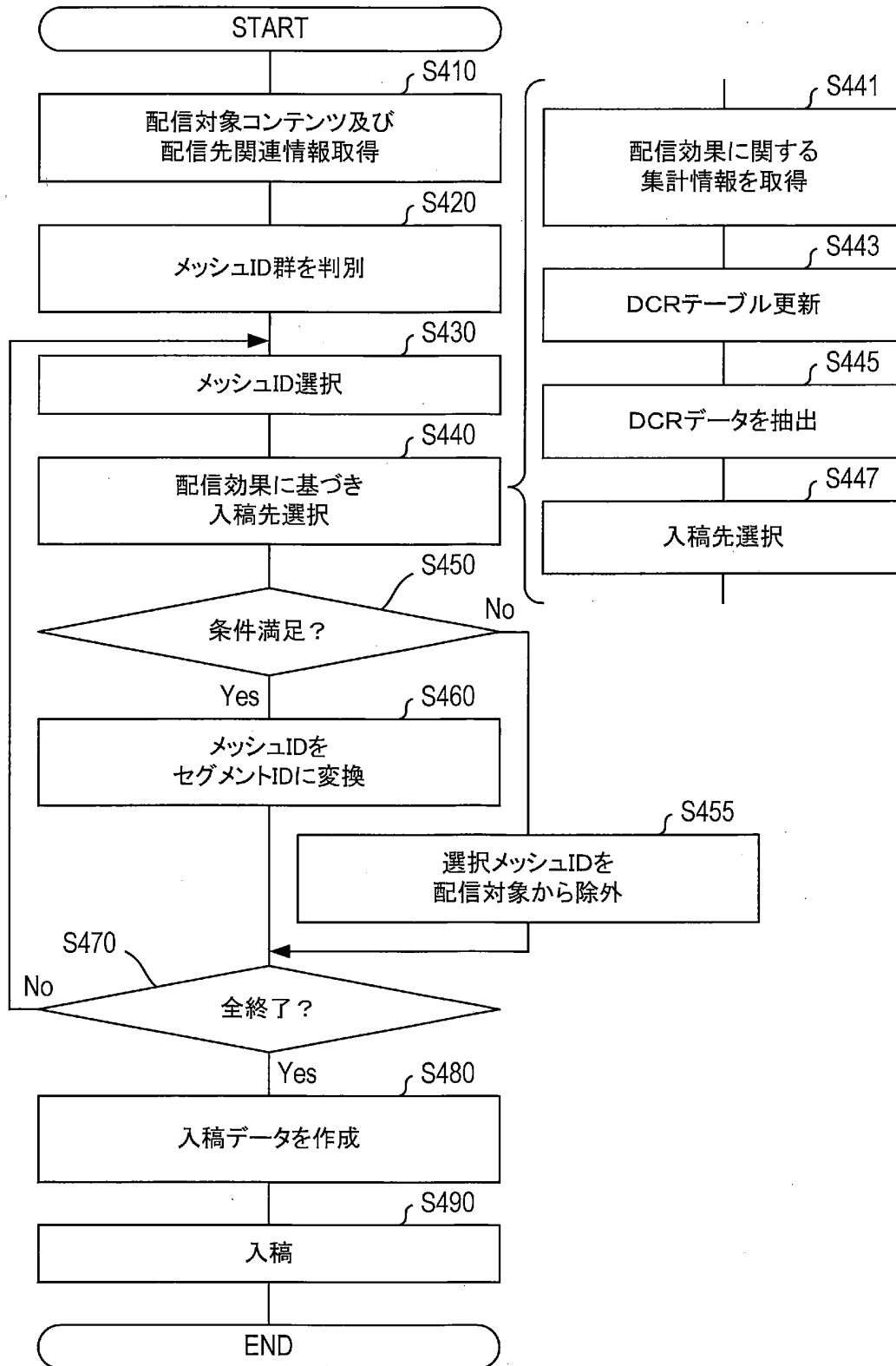


FIG. 15

[図16]

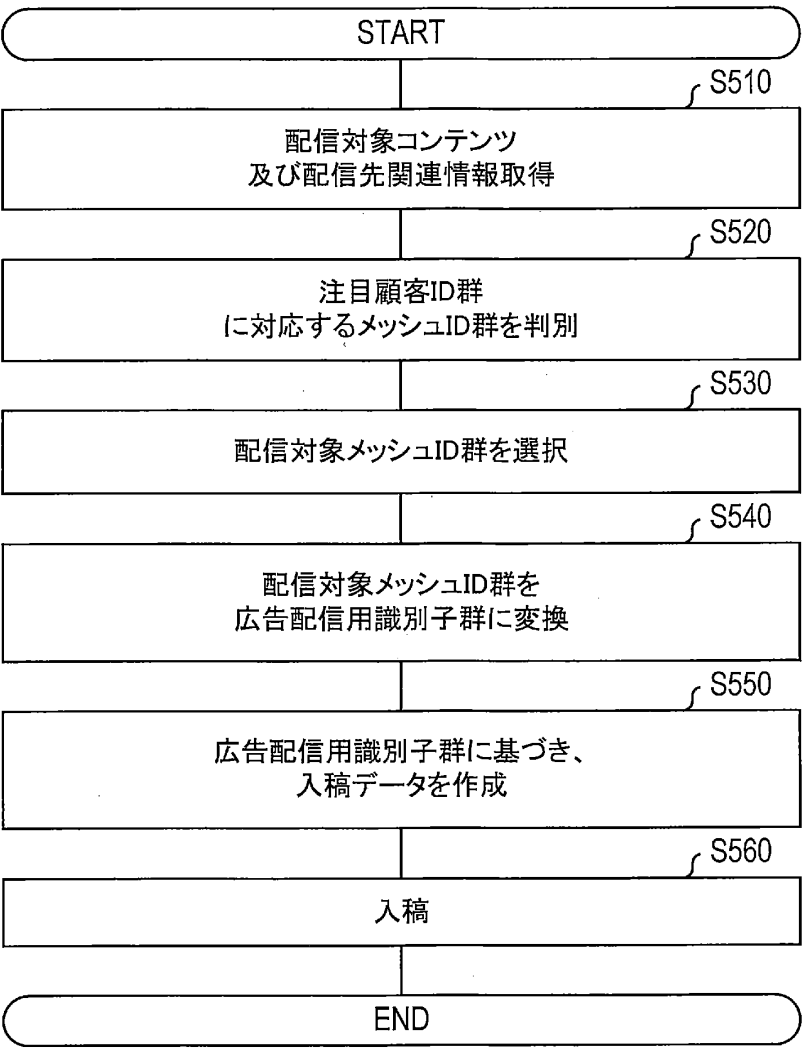


FIG. 16

[図17]

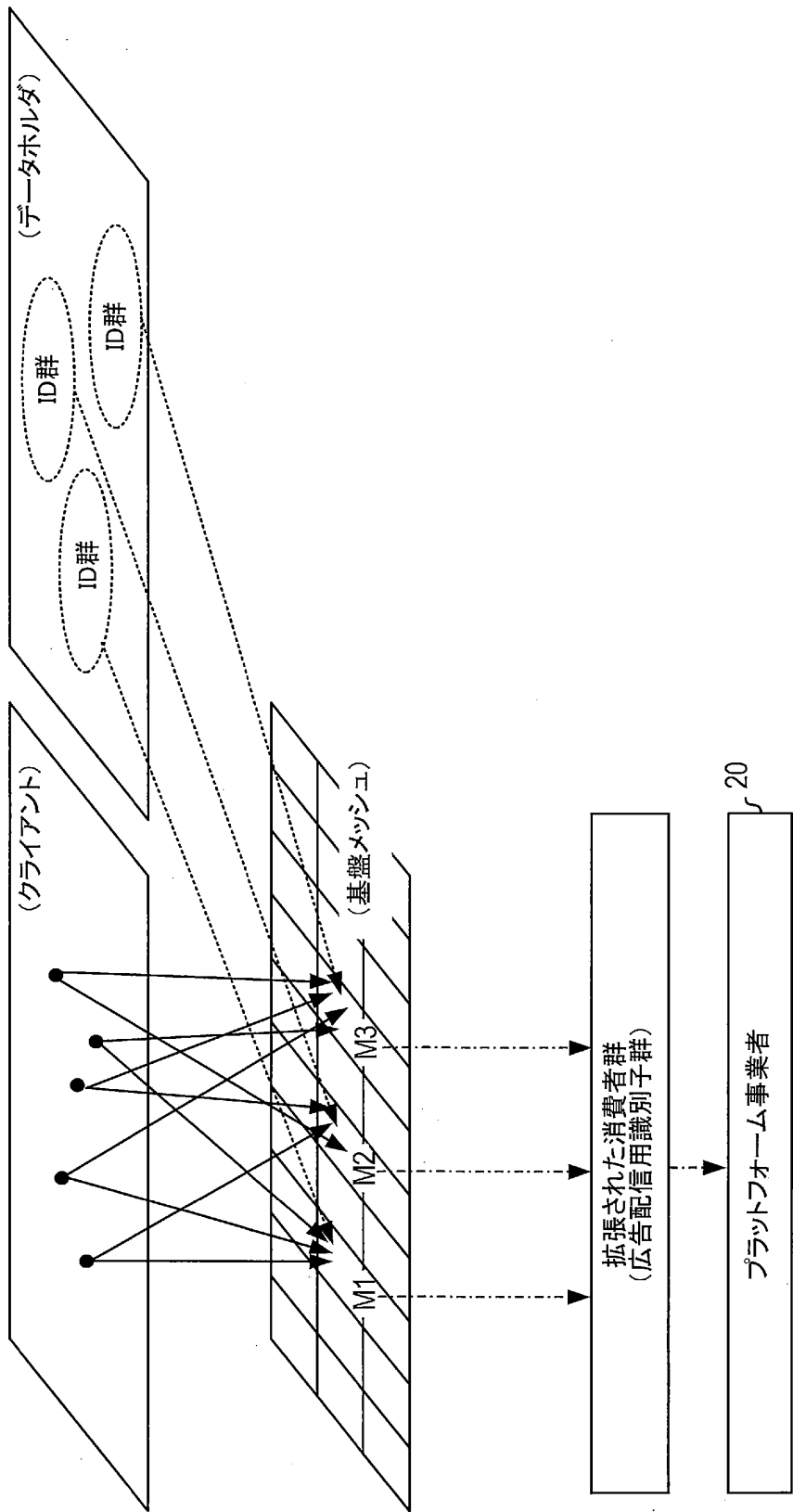


FIG. 17

[図18]

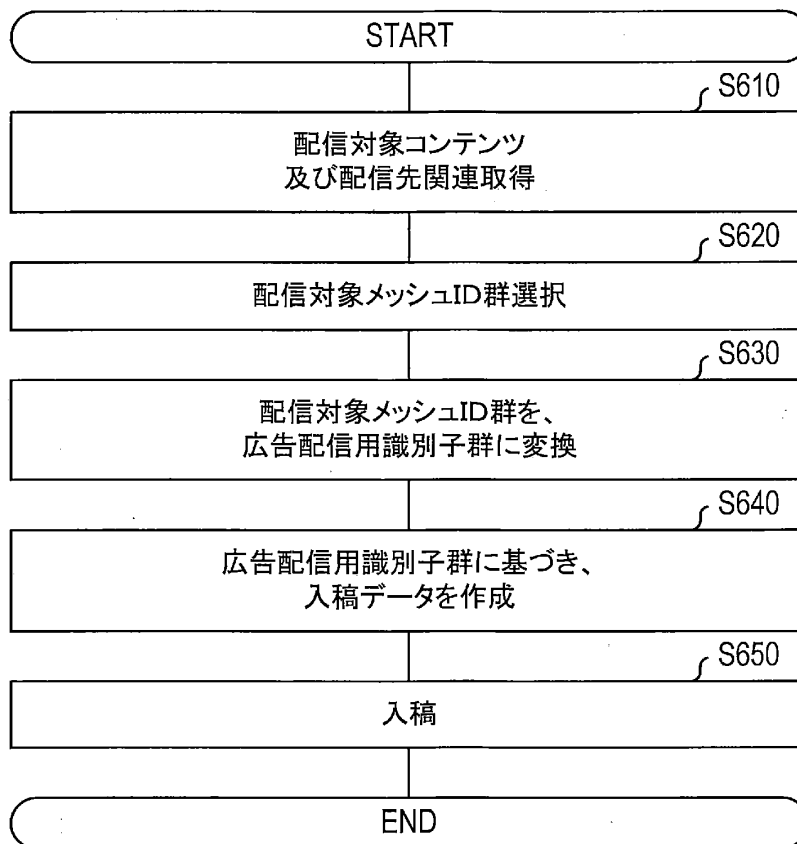


FIG. 18

[図19]

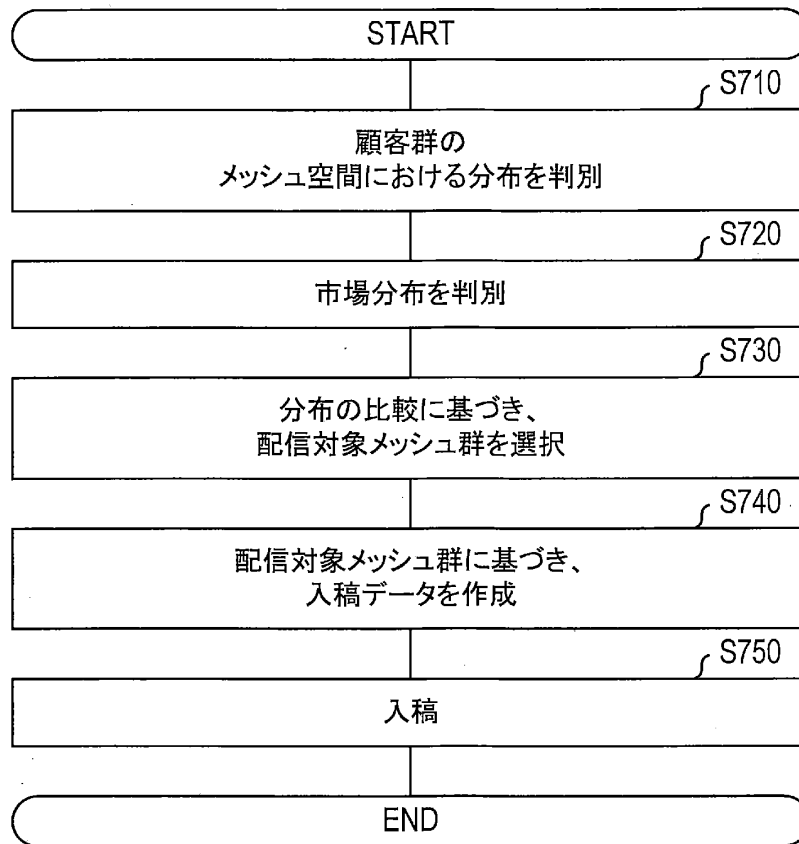


FIG. 19